

Title (en)
Electrostatic mems switch

Title (de)
Mikroelektromechanische elektrostatische Schalter

Title (fr)
Interrupteur électrostatique et microélectromécanique

Publication
EP 1426992 A3 20051130 (EN)

Application
EP 03104514 A 20031203

Priority
JP 2002354041 A 20021205

Abstract (en)
[origin: EP1426992A2] A plurality of fixed contacts and signal lines are provided on a fixed substrate. A movable contact which is closed or opened with the fixed contacts is provided on a movable substrate opposed to the fixed substrate. A film thickness of the fixed contacts is made to be smaller than that of the signal lines so that the movable contact is set in a concave portion constituted by the fixed contacts when the fixed contacts, and the movable contact are closed and the signal lines are linearly connected. <IMAGE>

IPC 1-7
H01H 59/00

IPC 8 full level
H01H 59/00 (2006.01); **H01P 1/12** (2006.01)

CPC (source: EP)
H01H 59/0009 (2013.01); **H01P 1/127** (2013.01); **H01H 2001/0084** (2013.01); **H01H 2059/0054** (2013.01)

Citation (search report)

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AT BE BG CH CY CZ DE DK EE ES FI FR GB GR HU IE IT LI LU MC NL PT RO SE SI SK TR

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